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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

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Application Number	10/788,685
Filing Date	02/27/2004
First Named Inventor	Choi et al.
Group Art Unit	1756
Examiner Name	Young, Christopher G.
Attorney Docket Number	PA130-06D09

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
Chy	A1	4,070,116		Frosch et al.	01-24-1978	Class 505 Sub
Chy	A2	4,600,309		Fay	07-15-1986	
	A3	4,848,911		Uchida et al.	07-18-1989	
	A4	5,074,667		Miyatake	12-24-1991	
	A5	5,148,036		Matsugu et al.	09-15-1992	
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	A8	5,179,863		Uchida et al.	01-19-1993	
	A9	5,376,810		Hoenk et al.	12-27-1994	
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	A16	6,150,680		Eastman et al.	11-21-2000	
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	A20	6,482,742	B1	Chou	11-19-2002	
	A21	6,534,418	B1	Plat et al.	03-18-2003	
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Chy	A34	5,431,777		Austin et al.	07-11-1995	
Examiner Signature	<i>Chy Chy</i>			Date Considered	1/2005	

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Sheet

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Attorney Docket Number	PA130-06D09

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		Number	Kind Code ² (If known)			
	A35	5,422,295		Choi et al.	06-06-1995	
	A36	5,421,981		Leader et al.	06-06-1995	
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Examiner Signature

Chris Young

Date Considered

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	A70	5,071,694		Uekita et al.	12-10-1991	
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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	10/788,685
				Filing Date	02/27/2004
				First Named Inventor	Choi et al.
				Group Art Unit	1756
				Examiner Name	Young, Christopher G.
Sheet	4	of	8	Attorney Docket Number	PA130-06D09

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				Filing Date	02/27/2004
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Sheet	5	of	8	Attorney Docket Number	PA130-06D09

FOREIGN PATENT DOCUMENTS

Examiner Signature *Ch. Ch.* **Date Considered** *1/2005*

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
<i>Cuy</i>	A122	Abstract of Japanese Patent 63-138730	
<i>AB</i>	A123	Abstract of Japanese Patent 55-88332	
	A124	Abstract of Japanese Patent 57-7931	
	A125	Abstract of Japanese Patent 02-92603.	
	A126	Translation of Japanese Patent 02-92603.	
	A127	Abstract of Japanese Patent 02-24848.	
	A128	Translation of Japanese Patent 02-24848.	
	A129	HEIDARI et al., "Nanoimprint Lithography at the 6 in. Wafer Scale," Journal of Vacuum Science Technology, Nov/Dec 2000, pp. 3557-3560, vol. B, no. 18(6)/	
	A130	NERAC.COM Retro Search, "Reduction of Dimension of Contact Holes", August 31, 2004	
<i>S</i>	A131	NERAC.COM Retro Search, "Trim Etching of Features Formed on an Organic Layer", September 2, 2004	
<i>Cuy</i>	A132	NERAC.COM Retro Search, "Multi-Layer Resists", September 2, 2004	

Examiner Signature

Christopher G. Young

Date Considered

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<i>Chy</i>	A133	HU et al., "Flourescence Probe Techniques (FPT) for Measuring the Relative Efficiencies of Free-Radical Photoinitiators", s0024-9297(97)01390-9; "Macromolecules" 1998, vol. 31, no.13 , pp. 4107-4113, 1998 American Chemical Society. Published on Web 05/29/1998	
<i>Chy</i>	A134	FEYNMAN, Richard P., "There's Plenty of Room at the Bottom—An Invitation to Enter a New Field of Physics," 12 pp [online][Retrieved 9/23/04 from URL: http://www.zyvex.com/nanotech/feynman.html]	
	A135	CIBA SPECIALTY CHEMICALS BUSINESS LINE COATINGS, "What Is UV Curing?", 45 pp [online][Retrieved 9/24/04 from URL: http://www.cibasc.com/image.asp?id=4040]	
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	A137	Papirer et al., "The Grafting of Perfluorinated Silanes onto the Surface of Silica: Characterization by Inverse Gas Chromatography," August 1993, pp238-242, vol. 159, Issue 1.	
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	A140	Abstract of Hirai et al., "Mold Surface Treatment for Imprint Lithography," August 2001, pp 457-462, vol 14, No. 3.	
	A141	Sung et al., "Micro/nano-tribological Characteristics of Self-Assembled Monolayer and its Application in Nano-Structure Fabrication," July 2003, pp. 808-818, vol. 255, no. 7.	
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<i>Chy</i>	A143	Roos et al., "Nanoimprint Lithography with a Commercial 4 Inch Bond System for Hot Embossing," October 2001, pp. 427-435, vol. 4343.	

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